

IFW

Docket No. LAM-P1093



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Robert J. Steger  
SERIAL NO.: 10/630,584  
FILING DATE: July 29, 2003  
TITLE: Method for Balancing Return Currents in Plasma Processing Apparatus  
EXAMINER: Not Yet Assigned  
ART UNIT: 1753

**CERTIFICATE OF MAILING**

I hereby certify that this paper is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450, on the date printed below:

Date:

May 16 2005

Name:

Lisa Dewitt


COMMISSIONER FOR PATENTS  
P.O. Box 1450 Alexandria, VA 22313-1450

**STATUS REQUEST LETTER**

Please advise the status of the above-identified patent application.

Respectfully submitted,  
THELEN REID & PRIEST LLP

Dated: May 5, 2005

  
\_\_\_\_\_  
David B. Ritchie  
Reg. No. 31,562

Thelen Reid & Priest LLP  
P.O. Box 640640  
San Jose, CA 95164-0640  
Tel.: (408) 292-5800  
Fax: (408) 287-8040